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Substitute for form 1449A/B/PTO				<b>Complete If Known</b>	
				Application Number	10/733,523-Conf. #9060
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)				Filing Date	December 10, 2003
				First Named Inventor	Kevin L Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
DA		US-10/767,298	Filed 01-28-2004	Zheng et al.	
		US-11/027,825	Filed 12-29-2004	Derderian et al.	
		US-10/933,604	Filed 09-02-2004	Carpenter et al.	
		US-10/687,458	Filed 10-15-2003	Kubista et al.	
		US-10/683,424	Filed 10-10-2003	Mardian	
		US-10/839,316	Filed 05-05-2004	Saragiannis et al.	
		US-10/814,573	Filed 03-31-2004	Gealy et al.	
		US-11/043,629	Filed 01-25-2005	Rueger et al.	
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		US-3,630,881	12-28-1971	Lester et al.	
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25	US-4,269,625	05-26-1981	Molenaar	
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	US-4,438,724	03-27-1984	Doehler et al.	
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25	US-5,498,292	03-12-1996	Ozaki	

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55	US-5,500,256	03-19-1996	Watabe	
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	US-5,908,947	06-01-1999	Vaartstra	
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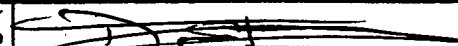
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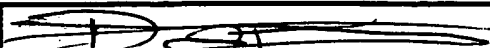
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	US-6,194,628	02-27-2001	Pang et al.	
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	US-6,197,119	03-06-2001	Dozoretz et al.	
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5	US-2001/0029892-A1	10-18-2001	Cook et al.	
	US-6,305,314	10-23-2001	Sneh et al.	
	US-6,309,161	10-30-2001	Hofmeister	
	US-6,315,859	11-13-2001	Donohoe	
	US-2001/0045187-A1	11-29-2001	Uhlenbrock	
	US-6,329,297	12-11-2001	Balish et al.	
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	US-6,342,277	01-29-2002	Sherman	
	US-6,346,477	02-12-2002	Kaloyeros et al.	
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8	US-6,432,831	08-13-2002	Dhindsa et al.	

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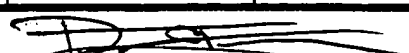


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				Filing Date	December 10, 2003
				First Named Inventor	Kevin L Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
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				Application Number	10/733,523-Conf. #9060
				Filing Date	December 10, 2003
				First Named Inventor	Kevin L Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
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Examiner Signature				Date Considered	12/2/05	

Substitute for form 1449A/B/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)				<b>Complete If Known</b>	
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				Filing Date	December 10, 2003
				First Named Inventor	Kevin L Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
				Attorney Docket Number	108298718US
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

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NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
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				Filing Date	December 10, 2003
				First Named Inventor	Kevin L Beaman
				Art Unit	1762
				Examiner Name	D. P. Turocy
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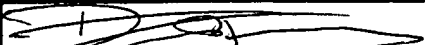
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